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(54) **Fuel cell utilizing solidous electrolyte.**

(57) A cell unit structure for stacking to form a fuel cell is described, composed of a porous substrate, a hydrogen electrode film formed of fine particles of nickel powder stacked on the porous substrate to form fine voids of homogeneous diameter, a film of solidous electrolyte stacked on the hydrogen electrode film, and an oxygen electrode film stacked on the electrolyte film.

**EP 0 414 270 A2**

## FUEL CELL UTILIZING SOLIDOUS ELECTROLYTE

### BACKGROUND OF THE INVENTION

#### Field of the Invention

The present invention relates generally to a fuel cell utilizing solidous electrolyte. Specifically, the present invention relates to a fuel cell which is composed of stacking solidous electrolyte thin film and a process for forming same.

#### Description of the Background Art

Fuel cells, such as plate type fuel cells are well known cell products utilizing porous substrates.

Generally, fuel cells for the production of electrical energy from a fuel and oxidant are well known in the art. Simply put, such cells are composed of a plurality of cell unit structures comprising sequentially stacked porous substrate, an anode electrode film, an electrolyte layer and a cathode electrode film, the cell units are connected in series. Hydrogen gas as fuel is provided in the cathode side of the fuel cell body and air (Oxygen gas) as oxidant is provided in the anode side thereof, then hydrogen and oxygen are reacted for producing electromotive force and water as a by-product. The electrolyte can be a solid, a molten paste, a free-flowing liquid, or a liquid trapped in a matrix. This invention is concerned with the solid type of electrolyte which is preferred for many applications.

It is also well known in the art that voltage dropping in a solidous electrolyte may be indicated by following formula:

$$V = iRt \times 10^{-4}$$

wherein V : voltage dropping

i : electric current (A)

R : resistance (ohm \* cm)

t : thickness of solidous electrolyte (μm)

From the above relationship, voltage dropping of fuel cell can be reduced corresponding to reducing the thickness of the solidous electrolyte. On the other hand, as a solidous electrolyte is formed on a thin electrode film over the porous substrate, the thickness of the electrolyte is determined by its coverage ability but must be thick enough to support a stacked cell structure, therefore, thinner is better but the minimum thickness is restricted. In view of these points, it has been assumed that thickness in a range of 10 to 50 μm is preferable for a solidous electrolyte layer.

Porous substrates generally in use have dispersed void sizes in a range of 0.5 to 40 μm. Numbers of pin holes are formed in both the electrode film and the solidous electrolyte where it is stacked on portions of the substrate having relatively large void sizes, when the thin electrode film with the solidous electrolyte are stacked on the substrate.

As well known in the art, electromotive force is produced at both sides of the solidous electrolyte when a concentration difference is created by a partial pressure difference of oxygen at each side. That is, the partial pressure difference forms a kind of concentration cell. The electromotive force of a fuel cell may be derived by the following formula:

$$E_0 = (RT/4F) \times \ln(P_1/P_2)$$

wherein R : gas constant

T : absolute temperature

F : Faraday constant

P<sub>1</sub>, P<sub>2</sub> : partial pressure of oxygen at both sides of the solidous electrolyte

As shown in the above formula, electromotive force E<sub>0</sub> proportionally increases corresponding to the ratio of the oxygen partial pressure. Therefore, any pin holes formed in the solidous electrolyte reduces the partial pressure difference of oxygen to zero, it causes loss of electromotive force or may even make the production thereof impossible. Avoid the formation of pin holes is greatly important for forming fuel cells.

### SUMMARY OF THE INVENTION

It is therefore the principal object of the present invention to provide a fuel cell utilizing solidous electrolyte inducing a minimum of voltage drop.

It is another object of the present invention to provide a fuel cell utilizing a thin solidous electrolyte in which the electrode surface to which the electrolyte is applied has fine voids of homogeneous diameter.

It is a further object of the present invention to provide a fuel cell utilizing solidous electrolyte which is free from pin holes.

It is a furthermore object of the present invention to provide a method for forming a fuel cell utilizing thin film of solidous electrolyte.

A fuel cell constructed of a plurality of cell unit structures stacked and connected in series, wherein the cell unit structure is composed of, a porous substrate, a hydrogen electrode film stacked on the porous substrate, the hydrogen electrode formed of fine particles of nickel powder having fine voids of

homogeneous diameter,  
a solidous electrolyte film stacked on the hydrogen  
electrode film, and  
an oxygen electrode film stacked on the solidous  
electrolyte film.

A process for forming the above-mentioned  
fuel cell, wherein the cell unit structure is formed  
by a process comprising the steps of: preparing a  
porous substrate for a base of the cell unit struc-  
ture,  
stacking a hydrogen electrode thin film having fine  
voids of homogeneous diameter on the porous  
substrate, wherein the film is formed by pressing a  
mixture of fine particles of nickel powder then  
sintering the mixture,  
stacking a solidous electrolyte film on the hydrogen  
electrode film, and  
stacking an oxygen electrode film on the solidous  
electrolyte film.

#### BRIEF DESCRIPTION OF THE DRAWINGS

The present invention will be understood from  
the detailed description given hereinbelow and  
from the accompanying drawings of the preferred  
embodiments which are given for explanation and  
understanding only and are not intended to imply  
limitation to the invention.

In the drawings;

Fig. 1 is a plan view of a conventional stacked  
cell;

Fig. 2 is a partial longitudinal sectional view of  
stacked unit structures of a conventionally used  
fuel cell;

Figs. 3 to 7 are enlarged cross sectional views  
showing a process of forming a thin film for a  
hydrogen electrode according to a procedure of  
the present invention.

#### DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENT

The present invention will now be described in  
detail referring to the accompanying drawings.

Referring now to Fig. 1, a fuel cell body 10 is  
composed of a plurality of cell unit structures S, a  
pair of fixing plates 11a and 11b to connect the  
stacked cell units S in series, a hydrogen path 12  
for providing hydrogen to a cathode plate side of  
each cell unit S, an oxygen path 13 for providing  
oxygen to an anode plate side of each cell unit S,  
and a pair of lead lines 14 and 15 to collect electric  
power from the cathode and the anode sides of  
each cell unit S. Both paths 12 and 13 which  
provide gas are installed on the outside of the cell  
body 10, and lead lines 14 and 15 are installed on

the outside of each cell unit S.

Electric power and water (as a by-product) are  
produced when hydrogen gas and air (oxygen  
gas), provided respectively, react through an elec-  
trolyte, then electric power produced is collected  
by the lead lines 14 and 15.

Fig. 2 is an enlarged longitudinal sectional view  
of stacked fuel cell bodies as shown in Fig. 1 which  
utilize a type of solidous electrolyte. A cell unit is  
composed of a lamination of a porous substrate 21  
formed of stainless steel, a hydrogen electrode film  
(a first electrode film) 22, a solidous electrolyte film  
23, and an oxygen electrode film (a second elec-  
trode film) 24, which are laminated sequentially.

The hydrogen electrode film 22 is formed on  
the porous substrate 21 as in the following exam-  
ple:

#### Example 1

As the porous substrate for the base of the  
hydrogen electrode, SUS316L (JIS standard) hav-  
ing about 40% of void ratio, 0.5  $\mu\text{m}$  of nominated  
void size and about 1 mm of thickness was used.  
Although the nominated void size is indicated as  
0.5  $\mu\text{m}$ , the actual void sizes are dispersed in a  
certain range, there are many voids having about  
10  $\mu\text{m}$ , sometimes up to about 40  $\mu\text{m}$ .

The porous substrate 21 was punched to a  
disc having 0.5 inch of diameter, then the disc was  
subjected to ultrasonic cleaning in a trichlene solu-  
tion followed by drying. The obtained substrate is  
shown in Fig. 3 diagrammatically.

Then nickel powder having a particle diameter  
of less than or equal to 1  $\mu\text{m}$  (hereinafter, sub-  
micron diameter) and nickel powder having particle  
diameter of 3  $\mu\text{m}$  were mixed at a volume ratio of  
1 : 1, and dissolved in water. The solution of the  
nickel powder mixture was applied uniformly on the  
porous substrate 21 as shown in Fig. 4. The ap-  
plied solution was dried at ambient temperature,  
then sintered at 1000 °C for 1 hour in a hydrogen  
atmosphere. Thus, a first nickel film 41 was  
formed.

The surface of the first nickel film 41 was  
polished as shown in Fig. 5, to remove projections  
therefrom. As an agent for the polishing, a #600  
grit paper was used. The polished nickel film 41  
was subjected to ultrasonic cleaning in deionized  
water and trichloroethylene solution for 10 min, the  
cleaned film was thereafter dried at ambient tem-  
perature. Then about 50 mg of nickel powder hav-  
ing a particle diameter of 3  $\mu\text{m}$  was applied uni-  
formly to the surface of the first nickel film 41 of  
the porous substrate 21, a pressure of about 700  
kg/cm<sup>2</sup>G was applied to the film, and the newly  
obtained film was sintered at 750 °C for 1 hour in

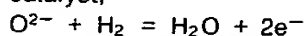
a hydrogen atmosphere. Thus, a second nickel film 61 was formed as shown in Fig. 6.

Nickel powder having submicron diameter was rubbed into the surface of the second nickel film 61, and pressure of about 700 kg/cm<sup>2</sup>G was applied to the film, nickel powder having submicron diameter was again rubbed into the surface of the pressed film, and the obtained film was again sintered at 750 °C for 1 hour in a hydrogen atmosphere. Thus, a third nickel film 71 was formed as shown in Fig. 7.

According to the above procedure, a hydrogen electrode film 22 having thickness of about 100 μm which was composed of the first nickel film 41, the second nickel film 61 and the third nickel film 71 laminated sequentially on the surface of the porous substrate 21, was obtained. Voids having diameter of 1 to 3 μm opened uniformly at the top surface thereof.

After forming the third nickel film 71, platinum (Pt) was laminated on the surface of the third film 71 to be about 200 μm thickness using sputtering technique. Sputtering was performed using a high frequency sputtering system targeting Pt under 5 x 10<sup>-2</sup> mmHg of pressure for 1 hour in an argon (Ar) gas atmosphere.

Coating of the surface of the third nickel film 71 by Pt is effective for promoting a reaction at the electrode indicated as follows, because Pt acts as catalyst;



Therefore, high electric power can be produced easily and quickly in the cell when coating of Pt is applied.

Further to say, as the preferred porous substrate, it may also be formed of nickel or copper. The porous substrate formed of nickel is formed by sintering the nickel powder, the void size of the obtained substrate becomes dispersed in a range of 3 to 50 μm as irregular surface which is formed according to configuration of nickel powder. As nickel powder has high adherence to the nickel powder electrode film, it has higher water resistance than a substrate formed of stainless steel. Alternatively, the porous substrate can also be formed of copper powder. As the configuration of copper powder is round, configuration of the voids can be rounded and the void size thereof becomes 3 to 40 μm which is similar to nickel powder. The porous substrate using the copper powder becomes an insulator when contacted with oxygen, therefore it cannot be used as the oxygen electrode but is most preferably used as a hydrogen electrode.

The solidous electrolyte 23 in Fig. 2 is formed as in the following examples;

#### Example 2

A 10 μm thickness solidous electrolyte film was formed on the Pt coated hydrogen electrode film 22 which was laminated on the porous substrate 21. An electron beam sputtering technique was applied to the forming, using a turbo-pump in a vacuum at 10<sup>-8</sup> mmHg. The temperature of the substrate was varied in a range of ambient to 580 °C, sputtering speed was controlled by a controller. As the material of the solidous electrolyte, single LaF<sub>3</sub> crystals were used, the solidous electrolyte film was formed under conditions of 500 °C of substrate temperature, 20 Å/sec of sputtering speed and -3.0 kV of accelerating voltage. Thus, a solidous electrolyte film having no pin holes was obtained.

#### Example 3

Resistance heating was applied to the forming, using a turbo-pump as mentioned in the first procedure in a vacuum at 10<sup>-8</sup> mmHg. The temperature of the substrate was determined at 400 °C, with a sputtering speed of 3 to 5 Å/sec. The forming was performed over about 5 to 6 hours. A 10 μm thickness solidous electrolyte film having no pin holes was obtained. La<sub>1-x</sub>SrF<sub>3-x</sub> can also be used as material for the solidous electrolyte. When X-ray diffraction was applied to the film obtained from La<sub>0.95</sub>Sr<sub>0.05</sub>F<sub>2.95</sub>, only a peak of LaF<sub>3</sub> was found. From this result, the obtained film of solidous electrolyte was not formed of a mixture of LaF<sub>3</sub> and SrF<sub>2</sub> but only of LaF<sub>3</sub>.

#### Example 4

A magnetron sputtering technique was applied to the forming, at a 400 °C substrate temperature under a pressure of 5.3 x 10<sup>-3</sup> mmHg in an Ar atmosphere. Sputtering was performed over 40 hours using a target of LaF<sub>3</sub> powder. A 10 μm film thickness was obtained. It was concluded from the results of X-ray diffraction tests, that the obtained film was formed an LaF<sub>3</sub> polycrystal having poor crystalline quality.

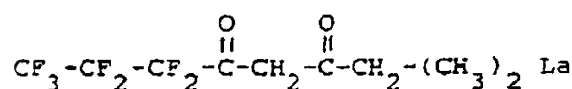
As the solidous electrolyte material it is preferable to use following compounds La<sub>0.95</sub>Sr<sub>0.05</sub>F<sub>2.95</sub>, La<sub>0.95</sub>Sr<sub>0.10</sub>F<sub>2.90</sub>, La<sub>0.95</sub>Ba<sub>0.05</sub>F<sub>2.29</sub>, or La<sub>0.90</sub>Ba<sub>0.10</sub>F<sub>2.29</sub>.

The composition of solidous electrolyte films obtained by sputtering techniques are similar to the composition of the original materials before sputtering even if materials having complex composition are used. Therefore, the sputtering method is preferred to thinner lamination qualities of materials

having complex compositions such as  $\text{La}_{0.95}\text{Sr}_{0.05}\text{F}_{2.95}$ .

#### Example 5

A metal organic chemical vapor deposition (MOCVD) technique was applied to forming the film of solidous electrolyte. Metal organic compounds including La and F in its molecule were heat-decomposed, then the obtained film of  $\text{LaF}_3$  was laminated on the Pt coated surface of the third nickel film 71 formed on the porous substrate 21 as shown in Fig. 6. The structural formula of the compound is following;



The film forming was accomplished under the following conditions, i.e., the temperature of the substrate was determined at  $600^\circ\text{C}$ , the temperature of the metal organic compounds was maintained at  $230^\circ\text{C}$ , with argon gas (Ar) as a carrier gas at flow rate of 100 ml/min. Steam of the metal organic compounds in a reactor was moved to the surface of the porous substrate 21 to react with it, thus a film of  $\text{LaF}_3$  was obtained.

#### Example 6

A high frequency sputtering technique was applied to forming the film of solidous electrolyte, using a high frequency sputtering system at the temperature of the substrate of  $800^\circ\text{C}$ , under the pressure of Ar at  $5.3 \times 10^{-3}$  mmHg. For a target, zirconia stabilized by addition of yttria was used. The sputtering was performed over 40 hours, and a  $10 \mu\text{m}$  thickness of film of solidous electrolyte having no pin holes was obtained thereafter. Compounds such as cerium oxide may also be used.

The oxygen electrode film 24 is formed as in the following examples;

#### Example 7

The oxygen electrode film was formed of perovskite compound. A perovskite compound of  $\text{La}_{0.6}\text{Sr}_{0.4}\text{CoO}_x$  was obtained by mixing powder of cobalt acetate  $(\text{CH}_3\text{COO})_2\text{Co} \cdot 4\text{H}_2\text{O}$ , lanthanum acetate  $(\text{CH}_3\text{COO})_2\text{La}$  and strontium acetate  $(\text{CH}_3\text{COO})_2\text{Sr}$ , which amounts thereof were weighed corresponding to a composition ratio of  $\text{La}_{0.6}\text{Sr}_{0.4}\text{CoO}_x$ . The mixture of powder as above described was baked at  $1000^\circ\text{C}$  for 5 hours in an

oxygen atmosphere. The electric resistance ratio of the obtained perovskite compound was  $4.4 \text{ ohm} \cdot \text{cm}$ .

The perovskite compound was dissolved in propylene glycol, then this solution was applied to the surface of the solidous electrolyte film 23, baked under pressure at  $300^\circ\text{C}$  for 8 hours in an oxygen atmosphere over 8 hours. Thus, an oxygen electrode film 24 as shown in Fig. 2 was obtained.

#### Example 8

A perovskite compound was formed as shown in Example 7.

The obtained compound was mixed with platinum black at a ratio of 3:1, then dissolved in propylene glycol. The mixture was applied to the surface of the solidous electrolyte film 23, then baked under the same conditions described in Example 7, thus an oxygen electrode film 24 was obtained.

#### Example 9

A perovskite compound was formed as shown in Example 7.

The obtained compound was then sputtered on the surface of the solidous electrolyte film 23 using a high frequency sputtering system. The sputtering was accomplished in an Ar atmosphere under a pressure of  $1 \times 10^{-2}$  mmHg, at  $0.5 \mu\text{m}/\text{hour}$  sputtering speed for 2 hours, thus about a  $1 \mu\text{m}$  thickness of oxygen electrode film 24 was obtained.

The perovskite compound as above mentioned has similar characteristics to platinum but is greatly less expensive.

#### Example 10

Ag powder was dissolved in propylene glycol then the obtained solution was applied to the surface of the solidous electrolyte film 23. The film was baked under pressure at  $300^\circ\text{C}$  in an oxygen atmosphere for 8 hours. Thus, an oxygen electrode film 24 was obtained.

#### Example 11

Chloroplatinic acid ( $\text{H}_2\text{PtCl}_6$ ) was dissolved in propylene glycol. The obtained solution was treated as described in Example 10, thus, an oxygen electrode film 24 was obtained.

Referring now again to Fig. 2, the porous sub-

strate, the hydrogen electrode film, the solidous electrolyte film, and the oxygen electrode film formed as previously described are stacked sequentially to form a cell unit structure. The cell unit is installed in a cell casing 25 having conductivity to electrically connect the hydrogen electrode film 22 of the cell unit with the casing 25. Concurrently, the oxygen electrode film 24 is connected electrically with a separator 27 which is adhered to the cathode side. A insulator 26 is installed between the cell casing 25 and the separator 27. Thus, a fuel cell body 40a is constructed. At the side of the porous substrate 21 of the cell body 40a, a conductive separator 27' is connected electrically with the cell casing 25 concurrently with the oxygen electrode film 24' at both sides of the separator 27'. A insulator 26' is installed between the separator 27' and the casing 25', thus a fuel cell body 40b is constructed and stacked with the cell body 40a. Similarly, fuel cell bodies 40c, 40d... (not shown in Fig. 2) are constructed and stacked sequentially. Therefore, a plurality of the cell units can be stacked connected in series. Oxygen, as an oxidant, is provided from gas inducing paths 29 and 29' to the cells, and hydrogen as fuel is provided from gas inducing paths 30 and 30' to the cells, thus, electric power is produced.

According to the present invention, as the hydrogen electrode is formed of fine powder mixture of nickel then sintered, void sizes can be homogenized. Thus, formation of pin holes on the films laminated on the electrode can be avoided even if a very thin solidous electrolyte film is laminated. Accordingly, voltage dropping can be reduced by reducing the thickness of the solidous electrolyte.

While the present invention has been disclosed in terms of the preferred embodiment in order to facilitate better understanding thereof, it should be appreciated that the invention can be embodied in various ways without departing from the principles thereof. Therefore, the invention should be understood to include all possible embodiments and modifications to shown embodiments which can be embodied without departing from the principle of the invention as set out in the appended claims.

## Claims

1. A fuel cell constructed of a plurality of cell unit structures stacked and connected in series, wherein said cell unit structure comprising;  
a porous substrate,  
a hydrogen electrode film stacked on the porous substrate, said hydrogen electrode formed of fine particles of nickel powder having fine voids of homogeneous diameter,  
a solidous electrolyte film stacked on the hydrogen

electrode film, and

an oxygen electrode film stacked on the solidous electrolyte film.

2. A fuel cell constructed of a plurality of cell unit structures stacked and connected in series, wherein said cell unit structure comprising;

a porous substrate,

a hydrogen electrode film stacked on the porous substrate, said hydrogen electrode formed of fine particles of nickel powder having fine voids of homogeneous diameter,

a coating of platinum stacked on the hydrogen electrode film,

a solidous electrolyte film stacked on the platinum coated, and

an oxygen electrode film stacked on the solidous electrolyte film.

3. A fuel cell constructed of a plurality of cell unit structures stacked and connected in series, wherein said cell unit structure comprises;

a porous substrate,

a hydrogen electrode film stacked on said porous substrate, said film formed of a mixture of a first nickel powder having diameter of less than or equal to 1  $\mu\text{m}$  and a second nickel powder having diameter of less than or equal to 3  $\mu\text{m}$ , for forming fine voids of homogeneous diameter,

a coating of platinum stacked on said hydrogen electrode film,

a solidous electrolyte film stacked on said platinum coating, and

an oxygen electrode film stacked on said solidous electrolyte film.

4. A fuel cell as set forth in claim 1, wherein said porous substrate is formed of stainless steel.

5. A fuel cell as set forth in claim 1, wherein said porous substrate is formed of nickel powder.

6. A fuel cell as set forth in claim 1, wherein said porous substrate is formed of copper powder.

7. A fuel cell as set forth in claim 1, wherein said homogeneous diameter of said voids is in a range of 1 to 3  $\mu\text{m}$ .

8. A fuel cell as set forth in claim 1, wherein said solidous electrolyte is formed of single  $\text{LaF}_3$  crystals.

9. A fuel cell as set forth in claim 1, wherein thickness of said solidous electrolyte film is 10  $\mu\text{m}$ .

10. A fuel cell as set forth in claim 1, wherein said oxygen electrode film is formed of a perovskite compound.

11. A process for forming a fuel cell as set forth in claim 10, wherein said perovskite compound is  $\text{La}_{0.6}\text{Sr}_{0.4}\text{CoO}_x$ .

12. A fuel cell as set forth in claim 1, wherein said oxygen electrode film is formed of a solution of silver.

13. A fuel cell as set forth in claim 1, wherein said oxygen electrode film is formed of a solution of



chloroplatinic acid.

14. A process for forming a fuel cell constructed of a plurality of cell unit structures stacked and connected in series, wherein a process for forming said cell unit structure comprising the steps of; preparing a porous substrate for a base of said cell unit structure,

stacking a hydrogen electrode film having fine voids of homogeneous diameter on said porous substrate, wherein the film is formed by pressing a mixture of fine particles of nickel powder then sintering the mixture,

stacking a solidous electrolyte film on the hydrogen electrode film, and

stacking an oxygen electrode film on the solidous electrolyte film.

15. A process for forming a fuel cell constructed of a plurality of cell unit structures stacked and connected in series, wherein a process for forming said cell unit structure comprising the steps of; preparing a porous substrate for a base of said cell unit structure,

stacking a hydrogen electrode film having fine voids of homogeneous diameter on said porous substrate, wherein the film is formed by pressing a mixture of fine particles of nickel powder then sintering the mixture,

sputtering platinum on the hydrogen electrode film to form a platinum coating,

stacking a solidous electrolyte film on the platinum coating, and

stacking an oxygen electrode film on the solidous electrolyte film.

16. A process for forming a fuel cell constructed of a plurality of cell unit structures stacked and connected in series, wherein a process for forming said cell unit structure comprising the steps of; preparing a porous substrate for a base of said cell unit structure,

stacking a hydrogen electrode film having fine voids of homogeneous diameter on said porous substrate, wherein said film is formed by pressing a mixture of a first nickel powder having diameter of less than or equal to 1  $\mu\text{m}$  and a second nickel powder having diameter of less than or equal to 3  $\mu\text{m}$ , then sintering said pressed mixture,

sputtering platinum on said hydrogen electrode film to form a platinum coating,

stacking a solidous electrolyte film on said platinum coating, and

stacking an oxygen electrode film on said solidous electrolyte film.

17. A process for forming a fuel cell as set forth in claim 14, wherein said porous substrate is formed of stainless steel.

18. A process for forming a fuel cell as set forth in claim 14, wherein said porous substrate is formed of nickel powder.

19. A process for forming a fuel cell as set forth in claim 14, wherein said porous substrate is formed of copper powder.

20. A process for forming a fuel cell as set forth in claim 14, wherein said hydrogen electrode film is formed by laminating a plurality of films of said nickel powder, each film thereof being pressed and sintered sequentially.

21. A process for forming a fuel cell as set forth in claim 15, wherein said hydrogen electrode film is formed by the steps of;

pressing and sintering a first nickel powder, polishing said sintered first nickel powder to form a first nickel film,

15 applying a second nickel powder to said first nickel film and pressing then sintering said second nickel powder to form a second nickel film, and

20 rubbing a nickel powder having a diameter of said first nickel powder into a surface of said second nickel film and pressing then sintering thereof to form a third nickel film having three layers.

22. A process for forming a fuel cell as set forth in claim 21, wherein said third nickel film is formed by repeating said rubbing, pressing and sintering steps.

23. A process for forming a fuel cell as set forth in claim 15, wherein said sputtering of platinum is accomplished by a high frequency sputtering technique.

24. A process for forming a fuel cell as set forth in claim 14, wherein said homogeneous diameter of said voids in said hydrogen electrode film is in a range of 1 to 3  $\mu\text{m}$ .

25. A process for forming a fuel cell as set forth in claim 14, wherein said solidous electrolyte film is formed of single crystals of  $\text{LaF}_3$ .

26. A process for forming a fuel cell as set forth in claim 14, wherein said solidous electrolyte film is formed by a high frequency sputtering technique.

27. A process for forming a fuel cell as set forth in claim 26, wherein said sputtering is accomplished by using a target selected from  $\text{LaF}_3$ , zirconia stabilized by yttria and cerium oxide.

28. A process for forming a fuel cell as set forth in claim 14, wherein said solidous electrolyte film is formed by an electron beam sputtering technique.

29. A process for forming a fuel cell as set forth in claim 14, wherein said solidous electrolyte film is formed by a resistance heating technique.

30. A process for forming a fuel cell as set forth in claim 14, wherein said solidous electrolyte film is formed by a magnetron sputtering technique.

31. A process for forming a fuel cell as set forth in claim 14, wherein said solidous electrolyte film is formed by a metal organic chemical vapor deposition technique.

32. A process for forming a fuel cell as set forth in claim 14, wherein thickness of said solidous elec-

trolyte film is 10  $\mu\text{m}$ .

33. A process for forming a fuel cell as set forth in claim 14, wherein said oxygen electrode film is formed of a perovskite compound.

34. A process for forming a fuel cell as set forth in claim 33, wherein said perovskite compound is  $\text{La}_{0.6}\text{Sr}_{0.4}\text{CoO}_x$ .

35. A process for forming a fuel cell as set forth in claim 14, wherein said oxygen electrode film is formed of a solution of silver.

36. A process for forming a fuel cell as set forth in claim 14, wherein said oxygen electrode film is formed of a solution of a solution of chloroplatinic acid.

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Fig. 1

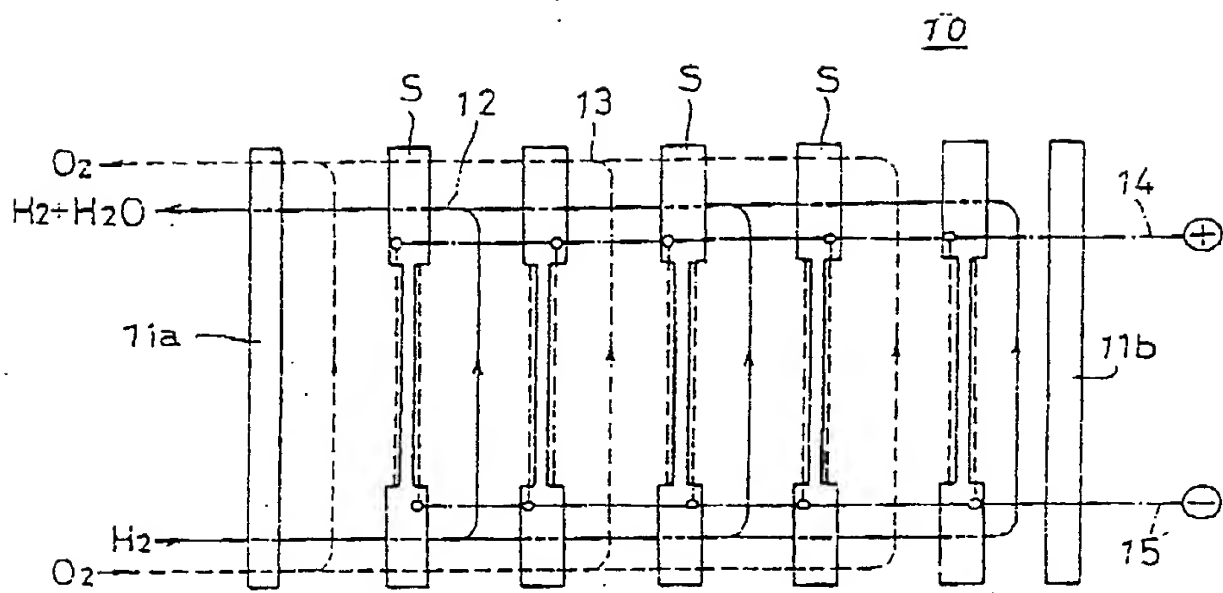


Fig. 2

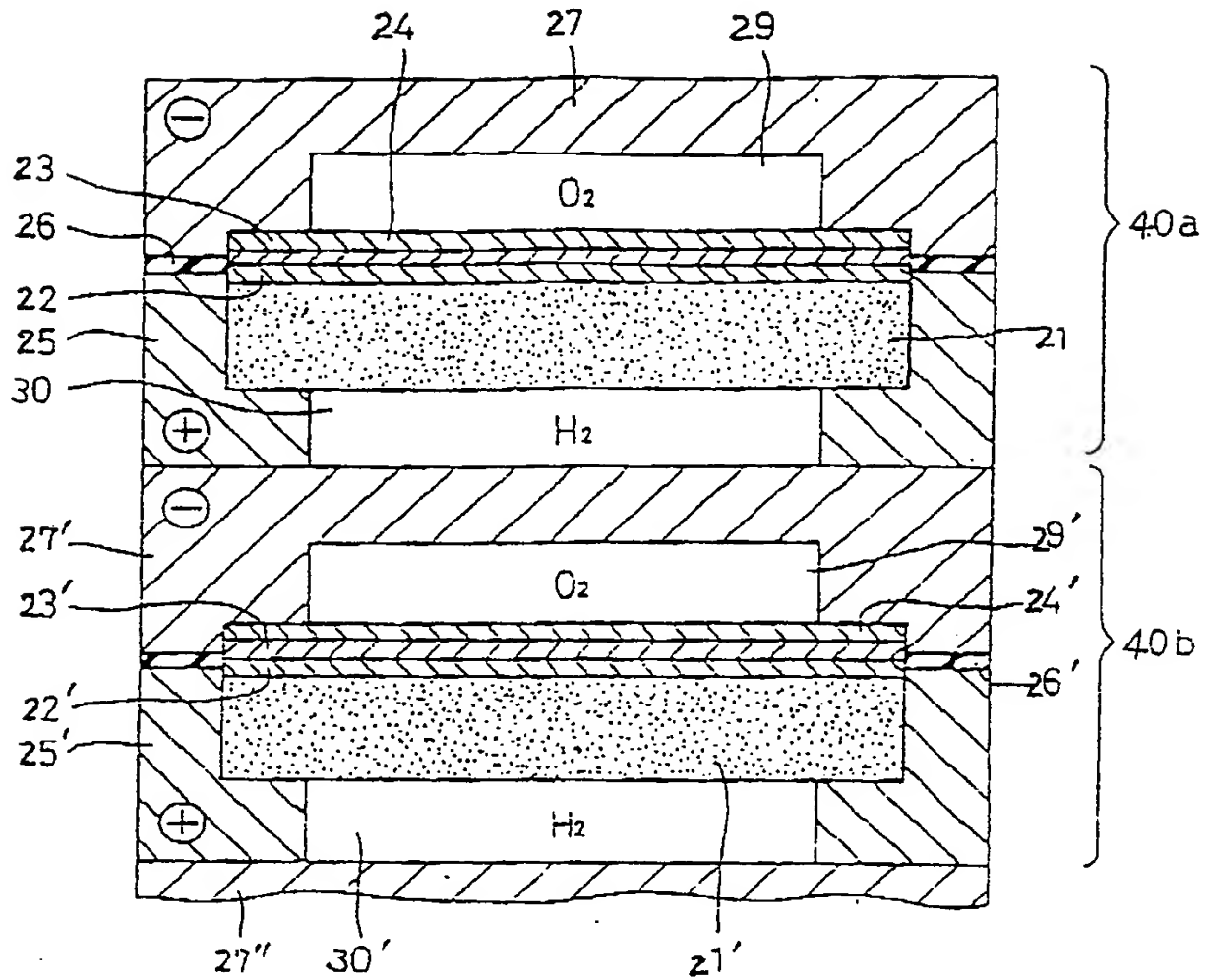


Fig. 3

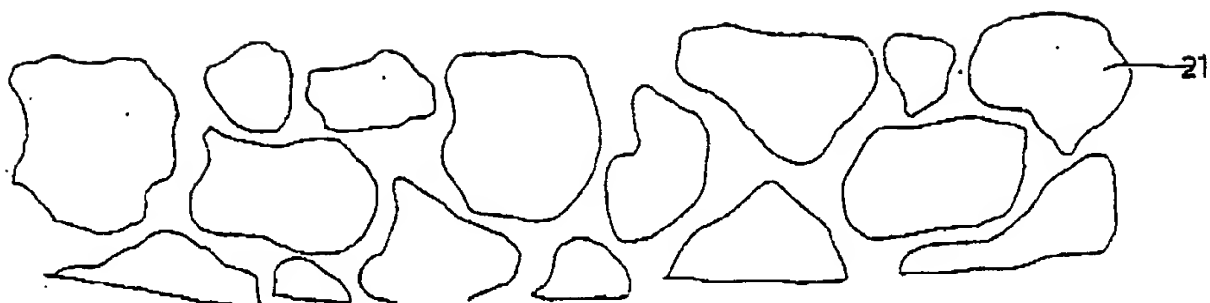


Fig. 4

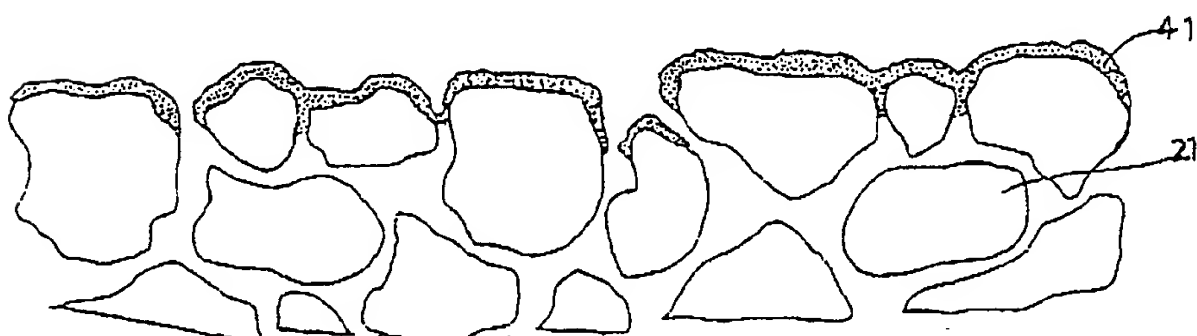


Fig. 5

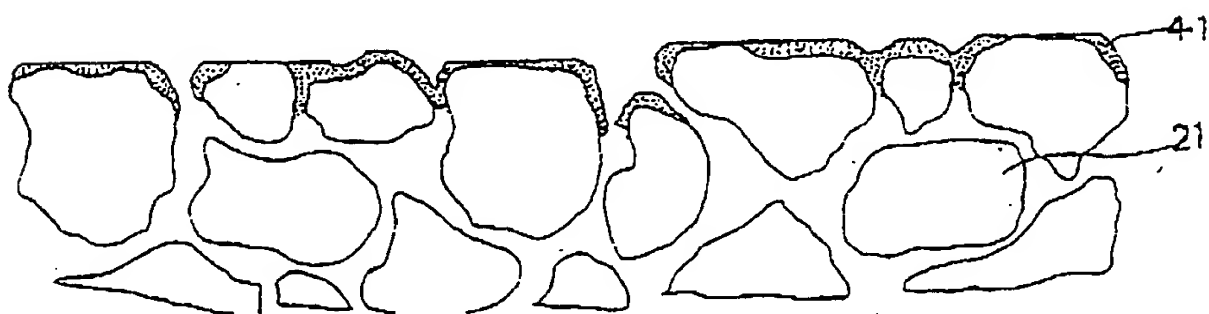


Fig. 6

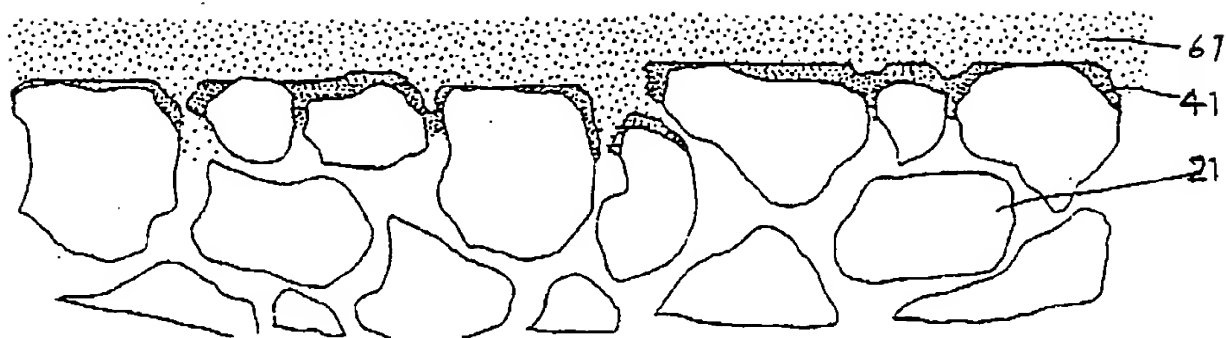
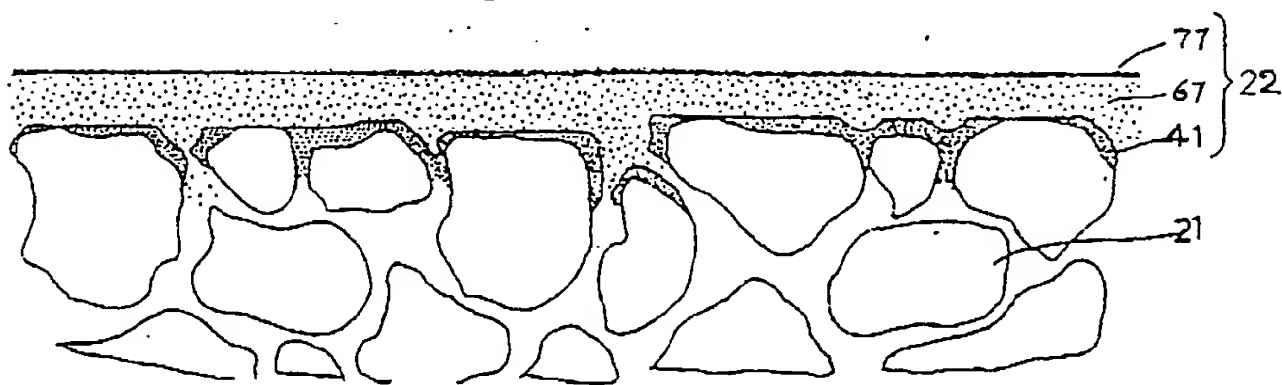


Fig. 7



(19)



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(54) **Fuel cell utilizing solidous electrolyte.**

(57) A cell unit structure for stacking to form a fuel cell is described, composed of a porous substrate (21), a hydrogen electrode film (22) formed of fine particles of nickel powder (41, 62, 72) stacked on the porous substrate to form fine voids of homogeneous diameter, a film of solidous electrolyte (23) stacked on the hydrogen electrode film, and an oxygen electrode film (24) stacked on the electrolyte film.

**EP 0 414 270 A3**



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## EUROPEAN SEARCH REPORT

Application Number

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DOCUMENTS CONSIDERED TO BE RELEVANT					
Category	Citation of document with indication, where appropriate, of relevant passages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int. Cl.5)		
X,Y	CH-A-5 156 22 (COMPAGNIE FRANCAISE DE RAF-FINAGE) * column 1, line 23 - column 2, line 18 ** column 3, line 51 - column 4, line 2 @ column 4, line 36 - line 44 @ column 6, line 3 - line 7; claims 1,2; figures 1-7 * - - -	1,4,5,9,8, 9,10,11	H 01 M 8/12 H 01 M 8/10 H 01 M 4/86 H 01 M 8/24		
Y,A	WO-A-8 804 108 (SRI INTERNATIONAL) * page 11, line 7 - line 21; claims 4,5; figures 6,7 ** page 19, line 16 - line 21; example 4 @ page 20, line 21 - page 21, line 12 ** example 3 * - - -	8,10,11, 25,26,27			
Y	PATENT ABSTRACTS OF JAPAN vol. 13, no. 184 (E-751)(3532) April 28, 1989 & JP-A-01 010 576 (MITSUBISHI HEAVY IND LTD ) January 13, 1989 * the whole document * - - -	10,11			
P,Y	WO-A-8 911 739 (SRI INTERNATIONAL) * claims 1,6,7,11,20,21,23-25 ** page 30, line 17 - page 31, line 8; examples 4,5; table 3 ** page 34, line 1 - line 7 @ page 37, line 1 - page 38, line 11; figure 15 * - - -	8,9,10,11			
A	PATENT ABSTRACTS OF JAPAN vol. 12, no. 273 (E-639)(3120) July 29, 1988 & JP-A-63 053 863 (MITSUBISHI HEAVY IND LTD ) March 8, 1988 * the whole document * - - -	1	TECHNICAL FIELDS SEARCHED (Int. Cl.5)  H 01 M		
A	FR-A-2 182 650 (SOCIETE AUTOMOBILES CITROEN) * page 5, line 11 - line 21; figure 7 * - - -	1			
A	CHEMICAL ABSTRACTS, vol. 109, no. 14, October 3, 1988, Columbus, Ohio, US; abstract no. 113404X, YAMAZAKI YOHTARO AND ALL 'Preparation of zirconia thin film cells with metal supports for a planar fuel cell stack ' page 180 :column 1 ; * abstract * - - -  -/-	1			
The present search report has been drawn up for all claims					
Place of search  The Hague		Date of completion of search  10 September 91	Examiner  D'HONDT J.W.		
<table border="0"><tr><td><b>CATEGORY OF CITED DOCUMENTS</b> X: particularly relevant if taken alone Y: particularly relevant if combined with another document of the same category A: technological background O: non-written disclosure P: intermediate document T: theory or principle underlying the invention</td><td>E: earlier patent document, but published on, or after the filing date D: document cited in the application L: document cited for other reasons ----- &amp;: member of the same patent family, corresponding document</td></tr></table>				<b>CATEGORY OF CITED DOCUMENTS</b> X: particularly relevant if taken alone Y: particularly relevant if combined with another document of the same category A: technological background O: non-written disclosure P: intermediate document T: theory or principle underlying the invention	E: earlier patent document, but published on, or after the filing date D: document cited in the application L: document cited for other reasons ----- &: member of the same patent family, corresponding document
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DOCUMENTS CONSIDERED TO BE RELEVANT			
Category	Citation of document with indication, where appropriate, of relevant passages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int. Cl.5)
A	US-A-3 464 861 (K.R.WILLIAMS AND ALL) * claims 1,2,5-7 *	1,2,4,5	
A	US-A-3 525 646 (H TANNENBERGER AND ALL) * column 10, line 70 - column 11, line 12 * * column 11, line 43 - column 12, line 6 *	1	
A	PATENT ABSTRACTS OF JAPAN vol. 12, no. 153 (E-607)(3000) May 11, 1988 & JP-A-62 268 063 (MITSUBISHI HEAVY IND LTD ) November 20, 1987 * the whole document *	1	
The present search report has been drawn up for all claims			TECHNICAL FIELDS SEARCHED (Int. Cl.5)
Place of search The Hague		Date of completion of search 10 September 91	Examiner D'HONDT J.W.
<p><b>CATEGORY OF CITED DOCUMENTS</b></p> <p>X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document T : theory or principle underlying the invention</p> <p>E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons &amp; : member of the same patent family, corresponding document</p>			

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